

... for a brighter future







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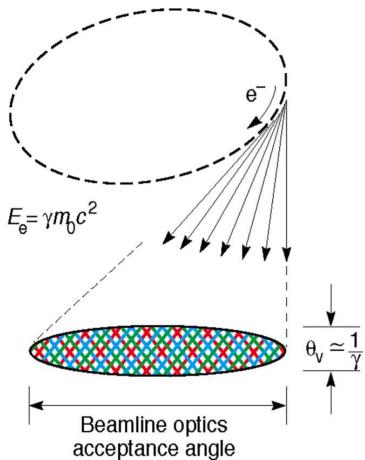
Basics of Synchrotron Radiation Beamlines and Detectors

- Basics of synchrotron radiation
- X-ray optics as they apply to EXAFS experiments
- Detectors

Important properties of Synchrotron Radiation

- Tunability
- High flux
- Collimation
- Polarization
- Time structure

Bending magnet radiation

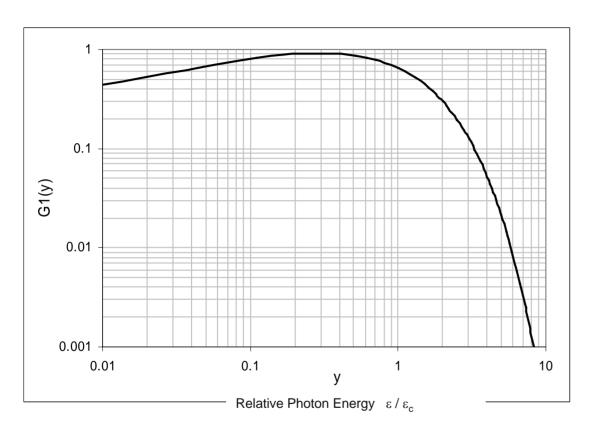


Emission limited to angle range $1/\gamma$.

 γ = 1957E(GeV)

For APS: $\gamma = 13699$ or $1/\gamma = 73$ µrad

Tunability – Bending magnet



Emitted Radiation has Characteristic Photon Energy

$$\varepsilon_c = 0.665 \, B_{\circ} \, E^2$$

 ε_c – Critical Photon Energy [keV]

E – Electron Energy in [GeV]

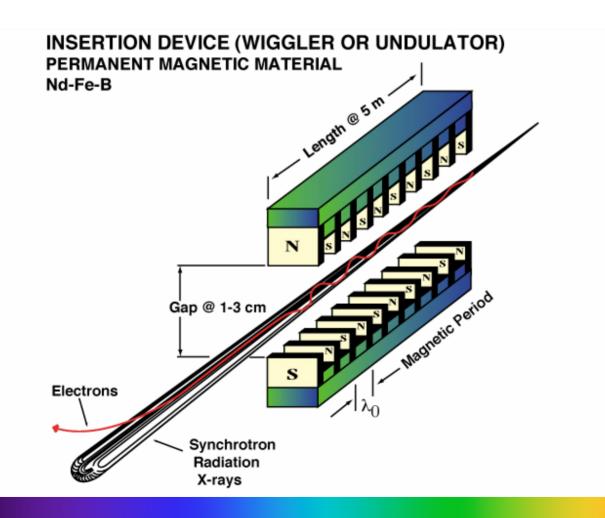
B_o – Magnetic Field in [Tesla]

Flux / mrad / 0.1 % BW = 2.457 \times 10 13 E I G 1 (y)



Insertion device

Many bends to increase flux over single bend in bending magnet

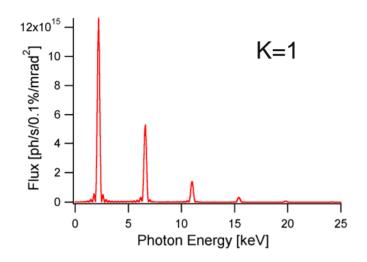


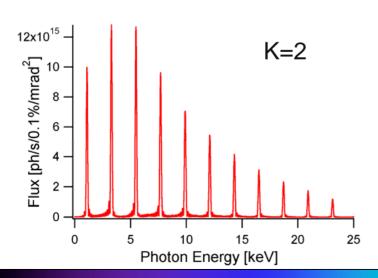


APS Undulator A



Tunability - Undulators



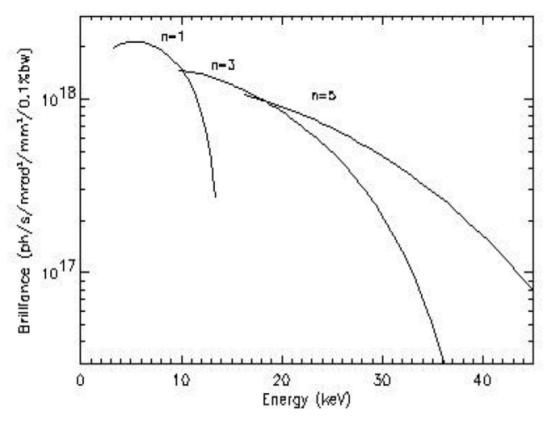


Undulator energy tuned by varying its K value – usually by tuning the magnetic gap which varies B

 $K = 0.0934 \lambda_u \text{ [mm] B}_o \text{ [T]}$



Undulator A tuning curve



Each curve follows one of the harmonics as K (gap) is varied

Figure 3. Tuning curves for the on-axis brilliance for the first three odd harmonics.

Source characterization

Flux – photons/sec/bandwidth
Bandwidth usually chosen as 0.1%
Most applications use 0.01-0.02%

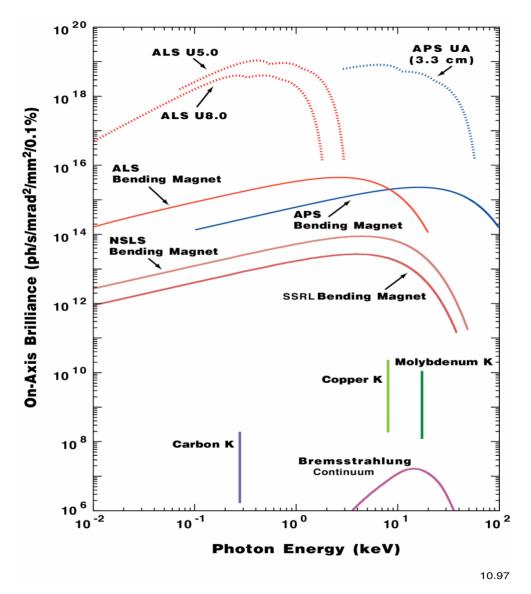
Spectral Brilliance - flux/source size/source divergence Photons/sec/0.1% bandwidth/mm²/mrad²

Liouville's theorem – brilliance is conserved Optics can't improve brilliance of source

Higher Brilliance implies more flux on small samples



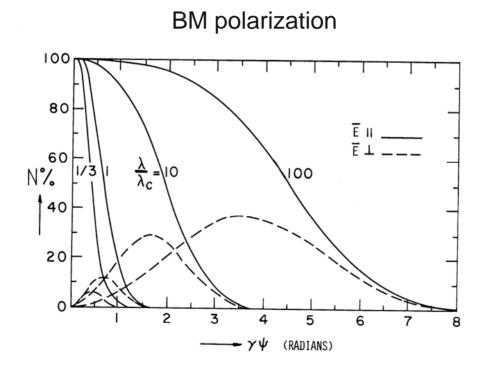
Comparison of source brilliance





Polarization

Both BM and standard ID's primarily polarized in the horizontal Fully polarized on axis



VERTICAL ANGULAR DISTRIBUTION OF PARALLEL AND PERPENDICULAR POLARIZATION COMPONENTS



Time structure

Storage rings store charge in discreet bunches

- Short pulses (100psec)
- 272 kHz circulation rate for an individual bunch at APS
- Many patterns possible (24, 324, 1296 bunches, hybrid fill with an isolated bunch)
- Generally not important, but can affect the deadtime of fast detectors

Current gradually decays

- Close shutters to refill
- Topoff: refill with shutters open



X-ray Optics

- Mirror Optics
 - Focusing and collimation (energy resolution)
 - Harmonic rejection
- Perfect crystals
 - Monochromatization
- Typical beamline setups



Mirror optics

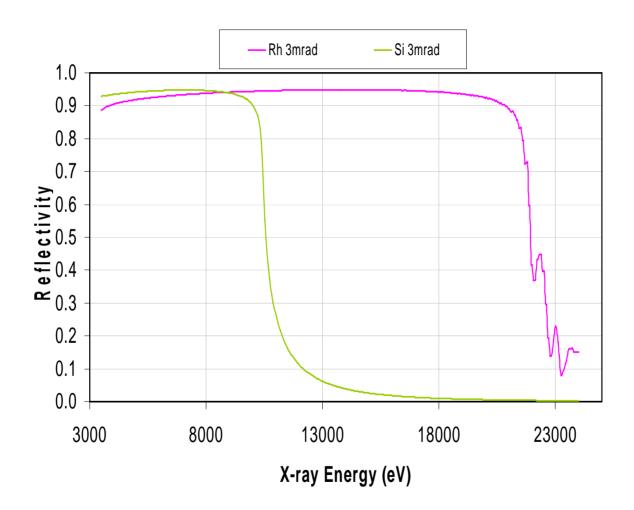
Glancing angle optics needed for x-rays

- For small enough angles reflectivity nearly 100%
- Achromatic for energies less than critical energy
- Ultra-smooth surfaces needed (0.5 nm roughness)
- Critical energy approximately linearly related to angle
 For example, for Rh,

$$E_c(keV) = 68/angle(mrad)$$

Small angles mean mirrors need to be long

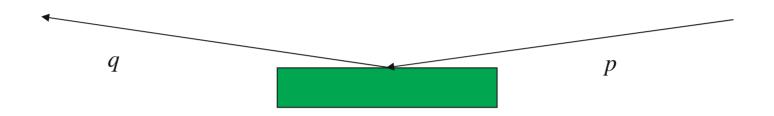
X-ray Reflectivity





Beamline mirrors

Collimating or focusing mirrors: typically ~1m long



Along beam:
$$R_m = \frac{2pq}{(p+q)\sin\theta}$$
 Typically km

Perpendicular to beam:
$$R_s = \frac{2pq\sin\theta}{p+q}$$
 Typically cm \Rightarrow limits collection angle

Magnification M=q/p

Toroidal (ellipsoidal) focusing mirror



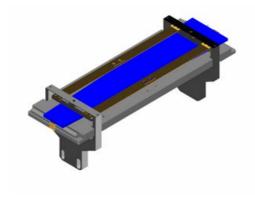
Glancing angles result in long narrow cylindrical shapes

Often approximated by a cylinder bent along beam direction

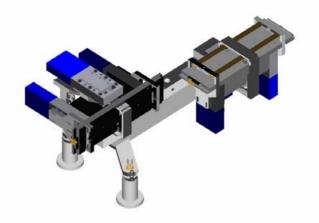


Kirkpatrick-Baez (K-B) mirrors

Separately focus the horizontal and vertical using elliptical mirrors



Individual mirror



Assembled KB mirrors



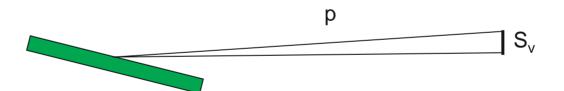
Collimating mirror

Need parabolic shape

$$q \rightarrow \text{infinity:}$$
 $R_m = \frac{2 p}{\text{s i n } \theta}$

Collimation limited by vertical source size:

$$\Delta\theta = S_v/p$$



X-ray Optics – perfect crystals

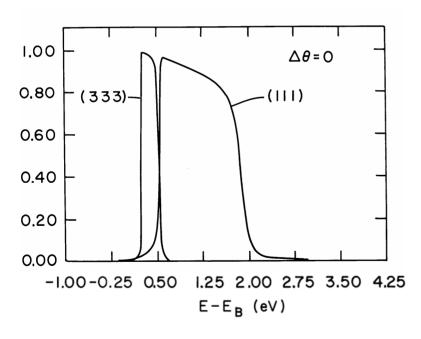
- Bragg reflection and energy resolution
- Monochromators
- Detuning



Bragg reflection basics

- Bragg equation
 - Bragg equation $2d\sin(\theta) = n\lambda$,
 - Perfect crystal Si or diamond reflectivity nearly 1 over finite range ΔE/E

Si 111 10 keV



Intrinsic Resolution of some common reflections

 λ =12.4/E(keV)

Reflection	ΔΕ/Ε
Si 111	1.3x10 ⁻⁴
Si 220	5.6x10 ⁻⁵
Si 311	2.7x10 ⁻⁵
Diamond 111	6.0x10 ⁻⁵



Energy Resolution

Depends on divergence and intrinsic resolution

From derivative of Bragg equation, divergence results in:

$$\Delta E/E = \cot(\theta)\Delta\theta$$

 $\Delta\theta$ determined by slits or collimating mirror if present

Example: 1mm slit 30 m from source at 10 keV with Si 111

$$\Delta\theta = 1/30000 = 3.3 \times 10^{-5}$$
, $\theta = 11.4$ or $\cot(\theta) = 4.9$

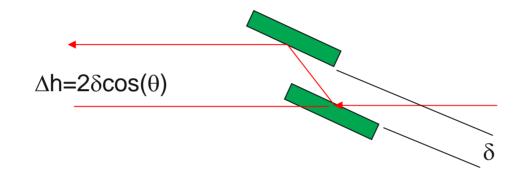
From divergence: $\Delta E/E = 3.3 \times 10^{-5} (4.9) = 1.6 \times 10^{-4}$

Add divergence term and intrinsic term in quadrature to get the approximate final resolution:

$$\Delta E / E = \sqrt{(1.6x10^{-4})^2 + (1.3x10^{-4})^2} = 2.1x10^{-4}$$
 (2.1 eV)

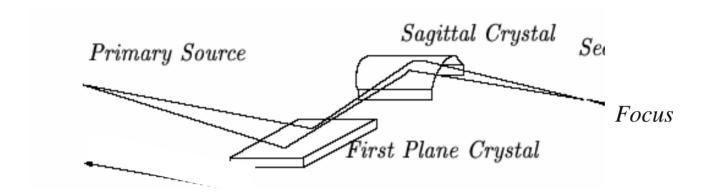
Double Crystal Monochromator

Use two crystals to minimize beam movement with angle change



For true fixed exit height need to change δ as angle changes

Horizontal focusing using sagittally bent crystal



Allows larger horizontal collection angle at higher energies

Crystal radius must change with angle

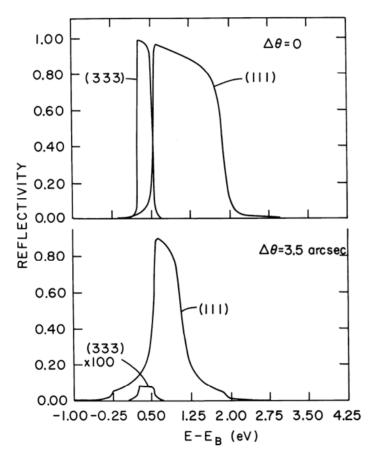
Anticlastic bending can be a problem – ribbed crystals

Detuning can be less effective at removing harmonics



Detuning

Detuning can be used to reduce the relative amount of harmonics in the beam



Note: detuning can also affect energy resolution



Some typical beamline layouts

- Monochromator only
 - Good for undulator, small beam size and divergence from source
- Monochromator with focusing mirror
- Collimating mirror monochromator focusing mirror
 - Typical setup for BM line, collimating mirror less useful at APS
- Collimating mirror sagittal focusing mono vertical focusing mirror
 - Can provide best flux from BM, may be difficult to optimize for spectroscopy



Detectors

- Signal to noise requirements
- Possible performance of ideal detectors
- Short description of some common detectors
 - Ion chambers
 - Multielement and deadtime issues
 - Filters and slits
 - Diffraction based detectors



S/N requirements

3 measurement regimes:

- ■Detection of element (imaging)
 - -S/N > 10
 - -10⁴ data points
- ■Near edge measurements
 - -S/N > 100
 - -50-100 data points
- ■Extended fine structure (EXAFS)
 - -S/N > 1000
 - -100-300 data points
- ■No background:

$$S/N = \sqrt{\text{detected counts}}$$

−For EXAFS need >10⁶ photons

Performance of Ideal Fluorescence Detector

- High flux beam provides > 10¹² ph/sec
- For EXAFS need > 10⁶ signal counts/pt
- Fluorescence yield 20-50%

If the absorption from the element of interest is about 10⁻⁶ of the total, a spectrum can be acquired in a few seconds/pt.



Practical limitations

- Can't collect 4π
 - Good goal is 25% of 4π
- Fluorescence absorbed in sample
 - Negligible for surface or thin sample
 - Maybe factor of 5 for thick sample
- Radiation Damage

10⁻⁶ absorption still feasible in 1-2 hrs.



Example for Fe

- 10⁻⁶ absorption gives 3x10¹³ atoms/cm²
 - small fraction of monolayer
- in solution:
 - 0.4 ppm by weight
 - 6 micromolar
- in Silicate mineral:
 - 5 ppm by weight



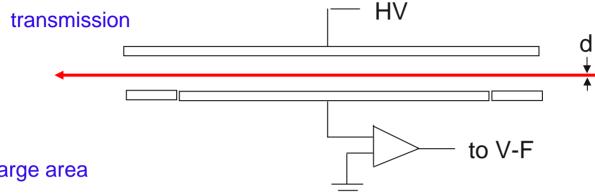
Current Detectors

Can be compared by effective count rate:

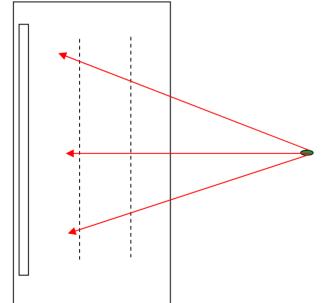
$$N_e = N_f / \sqrt{1 + N_b / N_f}$$

- Note: background scattering can be 1% of total absorption
- N_b can exceed 10⁸, ie $N_b/N_f \sim 100$
- Also need to consider total counting rate detector can accept

Ion chambers



Large area



Collection efficiency:

$$f = \frac{1}{1 + E^2 / 6} \qquad E = m \frac{d^2 \sqrt{q}}{V}$$

m~30-40, V is volt/cm

q is charge/cm³

For linearity want E small (V large and q small)



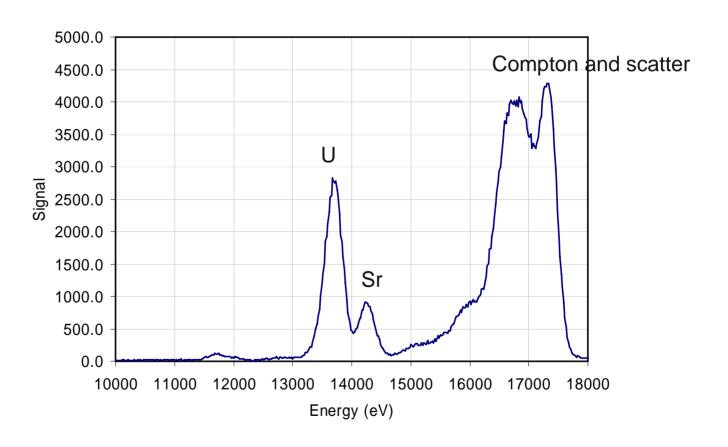
Multi-element solid state

- Resolution (fwhm) Ge: 200-300 eV, Si drift: 150-200 eV
- Individual element limited to few x 10⁵
- Background or lower energy fluorescence lines can saturate countrate
- Standard arrays limited to about 30 elements (100 possible in monolithic arrays)





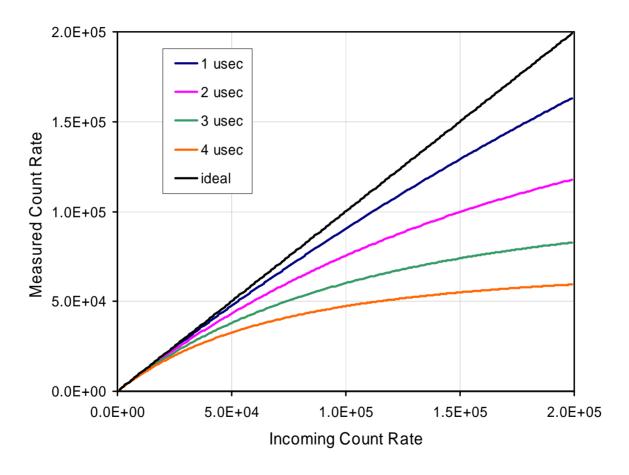
Typical spectrum- U contaminated Sediment



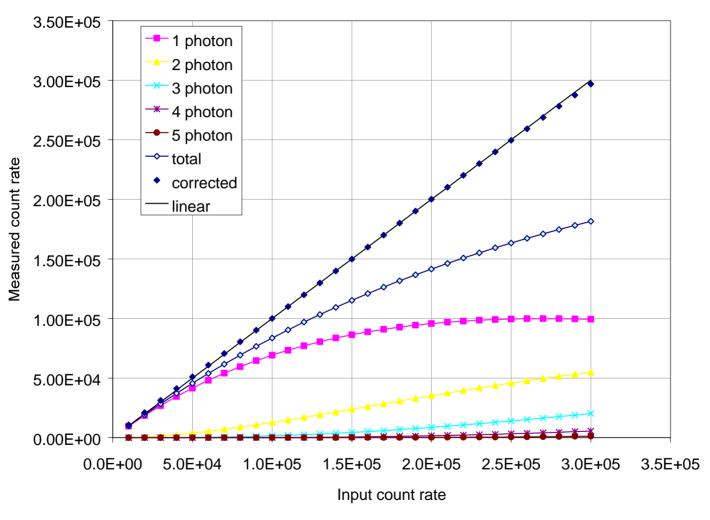
Dead time correction

Simple model:

MCR = ICR*Exp(-ICR*DT)



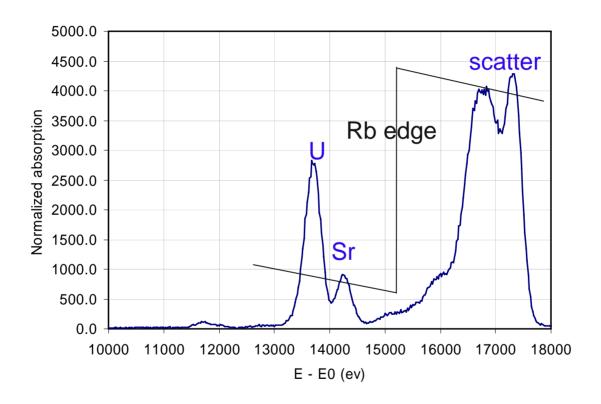
Pulsed source considerations



This is the single bunch case (272 kHz), for typical 24 bunch mode multiply the numbers by 24



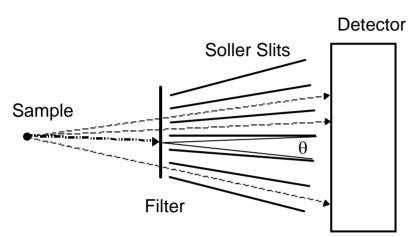
Filter can reduce the background in fluorescence measurement



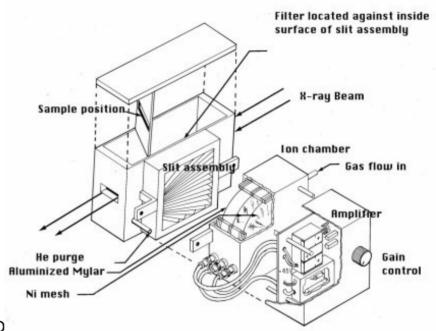
Problem: Rb fluorescence can enter the detector



Filter-slits (Stern-Heald or Lytle detector) see Stern and Heald, RSI 50, 1579 (1979)



- ■Large solid angle (large N_f)
- Unlimited count rate
- ■Moderate reduction in background N_b still p
- Little rejection of lower energy fluorescence lines
- Near practical limits
- ■Works best for K edges above 4 keV



Diffraction based detectors

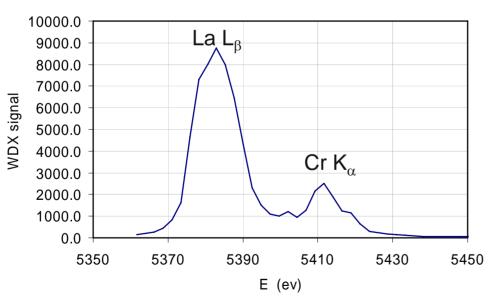
- Rowland circle, log-spiral (Bragg and Laue), multilayers
- Can have excellent resolution and background discrimination
- Unlimited count rates if integrating detectors used
- Usually require focused beam (0.1 mm)

WDX detector (Rowland circle)

Very good energy resolution and background discrimination

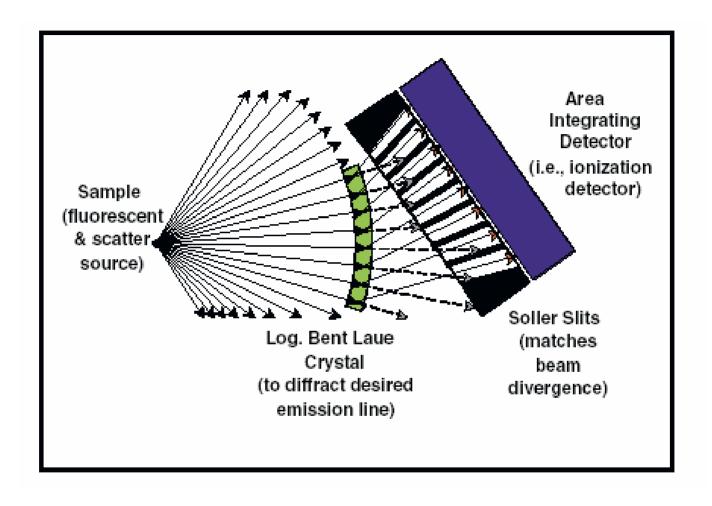
Poor collection efficiency

20 nm Cr doped TiO₂ on LaAlO₃

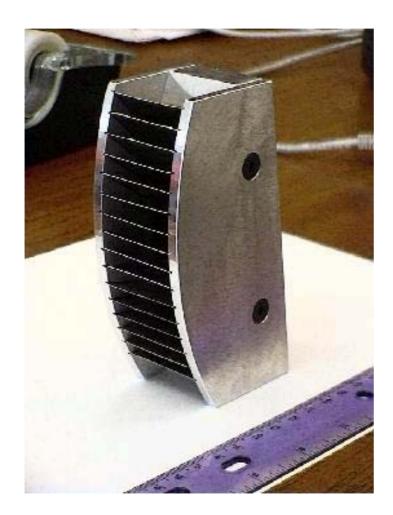




Log Spiral Laue detector

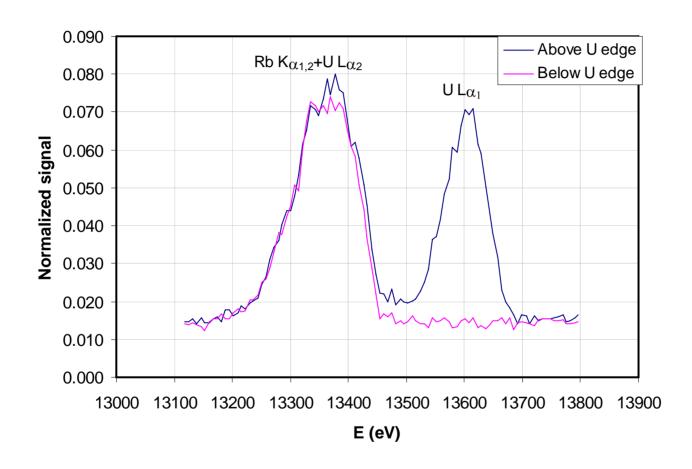


Log spiral detector (cont.)

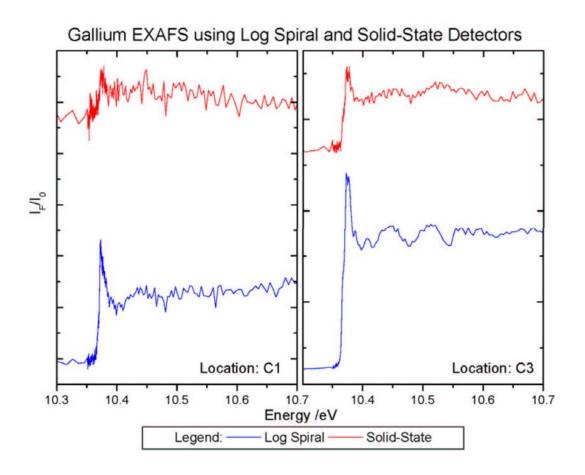


See: C. Karanfil, Z. Zhong, L.D. Chapman, R. Fischetti, G.B. Bunker, C.U. Segre, and B.A. Bunker, *SynchrotronRadiation Instrumentation, Eleventh U.S. NationalConference*, edited by P. Pianetta et al., Vol. **521**, pp. 178-182 (American Institute of Physics 2000).

Performance for detection of U



Detection of Ga in Nickel-Iron Meteorite courtesy of Ron Cavell – Univ. of Alberta





Further development of both solid-state arrays and diffraction-based detectors warranted

Solid state arrays:

- More elements coming (100-400 under development)
- Need to handle >108 hz
- Preferable to keep resolution close to 200 eV
- Si drift detectors look promising

Diffraction based detectors:

- Need to increase efficiency (multiple crystals)
- Should strive for better resolution than solid state detectors
- If above met, best bet for extreme diluteness
- Need 0.1-0.2 mm high beam

